

Notice of References Cited	Application/Control No. 10/656,392	Applicant(s)/Patent Under Reexamination HEMINWAY ET AL.	
	Examiner Kiley Stoner	Art Unit 1725	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-2005/0013558	01-2005	Powers, Michael	385/092
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	U	
	V	
	W	
	X	

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